

Subject card

Subject name and code	, PG_00052106								
Field of study	Nanowarstwy i nanopowłoki								
Date of commencement of studies	October 2022		Academic year of realisation of subject			2025/2026			
Education level	first-cycle studies		Subject group			Optional subject group Subject group related to scientific research in the field of study			
Mode of study	Full-time studies		Mode of delivery			at the university			
Year of study	4		Language of instruction			Polish			
Semester of study	7		ECTS credits			4.0			
Learning profile	general academic profile		Assessment form			assessment			
Conducting unit	Division of Nanomaterials Physics -> Institute of Nanotechnology and Materials Engineering -> Faculty of Applied Physics and Mathematics -> Wydziały Politechniki Gdańskiej							Faculty of	
Name and surname of lecturer (lecturers)	Subject supervisor	dr hab. inż. Marcin Łapiński							
	Teachers	dr hab. inż. M							
Lesson types	Lesson type Lecture		Tutorial Laboratory Pr		Projec	t	Seminar	SUM	
,,	Number of study hours	0.0	0.0	15.0	30.0		0.0	45	
	E-learning hours included: 0.0								
	eNauczanie source addresses: Moodle ID: 2054 Nanowarstwy i nanopowłoki https://enauczanie.pg.edu.pl/2025/course/view.php?id=2054								
Learning activity and number of study hours	Learning activity Participation in classes include plan				Self-study SUM		SUM		
	Number of study hours	45		5.0		50.0		100	
Subject objectives	The aim of the course is to familiarize students with fabrication techniques and methods used for the analysis of surface, structure, as well as optical and electrical properties applied in thin-film technology. Special attention will be given to the use of thin films in modern medical and analytical technologies								
Learning outcomes	Course out	Subject outcome			Method of verification				
	K6_W07		The student has theoretical bacground, especially including knowledge of the basics of thermodynamics, crystallography and chemistry			[SW3] Ocena wiedzy zawartej w opracowaniu tekstowym i projektowym [SW1] Ocena wiedzy faktograficznej			
	K6_U02		The student is able to solve scientific and technological problems related to thin films			[SU5] Ocena umiejętności zaprezentowania wyników realizacji zadania [SU2] Ocena umiejętności analizy informacji [SU1] Ocena realizacji zadania			
	K6_K04		take on the role of an expert			[SK5] Ocena umiejętności rozwiązywania problemów występujących w praktyce [SK4] Ocena umiejętności komunikacji, w tym poprawności językowej [SK3] Ocena umiejętności organizacji pracy [SK2] Ocena postępów pracy [SK1] Ocena umiejętności pracy w grupie			
	K6_U09		The student is able to plan and conduct an experiment, paying particular attention to energy consumption and other environmental aspects			[SU2] Ocena umiejętności analizy informacji [SU3] Ocena umiejętności wykorzystania wiedzy uzyskanej w ramach przedmiotu [SU1] Ocena realizacji zadania			

Subject contents	Laboratories classes: 1. Overview of basic thin film manufacturing methods, 2. Measurement and analysis of properties of the metallic thin films, Project classes: 1. Applications of thin films in medicine and analytics 2. Design of a sensor based on thin film technology,						
Prerequisites and co-requisites	Basic knowledge of thermodynamics, crystallography, as well as physics and chemistry						
Assessment methods and criteria	Subject passing criteria	Passing threshold	Percentage of the final grade				
	project presentation	51.0%	50.0%				
	lab report	51.0%	50.0%				
Recommended reading	Basic literature	Books and papers. Like eg. 1. Krishna Seshan, "Handbook of Thin Film Deposition" 2. Hartmut Frey, "Handbook of Thin Film Technology" 3. Catherine Picart et al. "Layer-by-layer films for biomedical applications"					
	Supplementary literature	Technological news from journals					
	eResources addresses						
Example issues/ example questions/ tasks being completed	Design of a biosensor based on thin-film technology Fabrication of a biocompatible thin film						
Practical activites within the subject	Not applicable						

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